Tatsuya Tsukamoto

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Objective

• To obtain a challenging position as a Process and Pixel Engineer where I can leverage my experience.

Summary

- Experience in developing image sensors for consumer camera production.
- Semiconductor research experience at graduate school.

Professional History

SONY SEMICONDUCTOR MANUFACTURING INC., Kumamoto

Apr. 2023 - Present

• Device Development Engineer (Apr. 2023 - Present)

Set up process flow of image sensor for consumer camera capable mass production.

- -Determined process conditions by communicating with process engineers and pixel design engineers.
- -Handled wafers to create prototypes.
- Determined the optimal Cpk (value of process performance).

Achievement:

As a device section leader, completed process flow setup of prototype within target date (3 month).

Education

KYUSYU UNIVERSITY, Fukuoka

Apr.2021 - Mar. 2023

Master of Engineering in Interdisciplinary Engineering Science
 Thesis Title: A simple sensor device for power cycle degradation sensing
 Power Device Engineering Lab, Prof. Wataru Saito

ARIAKE NATIONAL COLLEGE OF TECHNOLOGY, Fukuoka

Apr. 2019 - Mar. 2021

Bachelor of Engineering in Advanced Production and Information Systems Engineering
Thesis Title: Development of rotary single raw hammering device for exterior wall tile testing robot
Iwamoto Lab., Assoc. prof. Tatsuya Iwamoto

Additional Information

- TOEIC(IP) 785, Nov. 2023
- Peer-reserved journal articles; Tatsuta Tsukamoto, Shin-ichi Nishizawa, Wataru Saito, A simple sensor device for power cycle degradation sensing, Microelectronics Reliability, 10.1016/j.microrel.2023.115068, 147, 11, 115068, 2023.08.
- Received Student Encouragement Award at the Electronic Device/Semiconductor Power Conversion Joint Workshop, Institute of Electrical Engineers of Japan, 2022.12.